

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | | |
|-------------|---|-------------|----------------------|
| Applicant: | Luetzen et al. | Docket No.: | QIM 2004 SP 00115 US |
| Serial No.: | 10/721,225 | Art Unit: | 1792 |
| Filed: | November 26, 2003 | Examiner: | Tran, Binh X. |
| | | Conf. No.: | 5694 |
| For: | Method and Structures for Increasing the Structure Density and the Storage Capacitance in a Semiconductor Wafer | | |

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed July 30, 2009. Please amend the above-referenced application as follows.